

Application/Control No.	Applicant(s)/Patent under Reexamination	Applicant(s)/Patent under Reexamination	
10/691,653	ESCARY, JEAN-LOUIS	ESCARY, JEAN-LOUIS	
Examiner	Art Unit		
Jegatheesan Seharaseyon, Ph.D	1647		

SEARCHED					
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED					
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
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